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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

EPLY TO RESTRICTION REQUIREMENT DATED 01/17/2007

Atty. Docket No. FOC1130

Applicant:

Stephen H. Siegele

Application Number

10/716,195

Filed

11/18/2003

For

Modular Molecular Halogen Gas Generation

System

**Group Art Unit** 

Examiner

1754

Nguyen, Ngoc Yen M.

Confirmation No. 4128

Commissioner of Patents

P.O. Box 1450

Alexandria, VA 22313

Dear Sir:

## Certification Under 37 C.F.R. § 1.10

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as Express Mail to Addressee (Label No. EV734640065US in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313 on February 16, 2007.

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The Examiner states that restriction is required under 35 U.S.C. § 121 to one of the following inventions:

Group I:

Claims 1-9, drawn to a system for generating a molecular halogen gas

classified in class 422, subclass 118+;

Group II:

Claims 10-18, drawn to another system for generating molecular halogen gas

classified in class 204, subclass 193+; or

Group III:

Claims 19-21, drawn to a method for using a system to generate molecular

halogen gas classified in class 423, subclass 500+.

Applicant elects to prosecute Claims 1-9 of Group I with traverse. The traversal is based on an examination of all the claims not being a burden upon the Office.

Applicant does not believe any fees and due and owing. If any fees are required, or if any amounts have been overpaid, please appropriately charge or credit those fees to Deposit Account No. 50-3183 of Sprinkle IP Law Group.

Respectfully submitted,

Sprinkle IP Law Group

Dated: Feb. 16, 2007 1301 W. 25th St., Suite 408

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